



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Spooner et al. **GROUP:** 2826
SERIAL NO: 10/006,964 **EXAMINER:** T. Dickey
FILED: December 5, 2001
FOR: **METHOD AND DEVICE FOR PROTECTING MICRO
ELECTROMECHANICAL SYSTEMS STRUCTURES
DURING DICING OF A WAFER**

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CHANGE OF CORRESPONDENCE ADDRESS

Applicant's representative requests that the correspondence address for the above application be changed to:

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Respectfully submitted,

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, Mail Stop: Non-fee Amendment

Deborah M. Costello

12/9/04
Date